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Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 26, 2005.

William R. Allen

William R. Allen, Reg. No. 48,389

26 August 2005

Date

Applicant: David Fairbourn  
Serial No: 10/613,620  
Filing Date: July 3, 2003  
Art Unit: 1763  
Examiner: Jeffrie Robert Lund  
Title: SIMPLE CHEMICAL VAPOR DEPOSITION SYSTEM AND METHODS FOR DEPOSITING MULTIPLE-METAL ALUMINIDE COATINGS  
Confirmation No.: 4378  
Attorney Docket: MTCL-09

Cincinnati, Ohio 45202

August 26, 2005

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO ELECTION/RESTRICTION REQUIREMENT**

Sir:

In response to the Election/Restriction Requirement mailed on July 28, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 10 of this paper.